



# Research on radiation damage of fusion relevant materials carried out at Warsaw University of Technology

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## Outline

- Part I: Transmission electron microscopy investigations of self-damaged tungsten targets
- Part II: Miniaturized sample testing at Faculty of Materials Science / WUT  
(**Z. Pakieła** et al.)

EUROfusion Task under: PFC.SP3.1 - Role of neutron damage on retention mechanism and strength in W / Be

Partners: Institute of Plasma Physics, Garching, Germany  
Jožef Stefan Institute, Ljubljana, Slovenia

Goal: Evaluate defects morphology and distribution as well as dislocation density in the damaged W targets

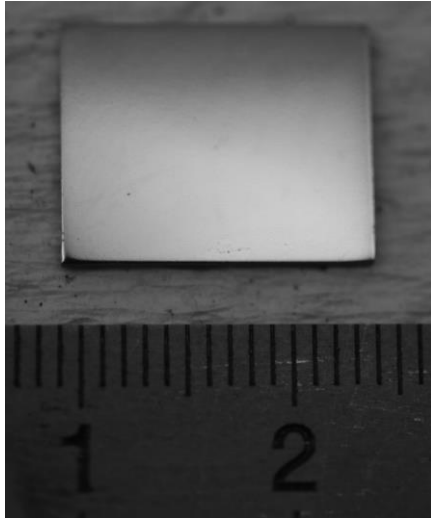
## Samples 2015

Sample number	Implantation conditions
1. A0780A	<b>20 MeV W ions, 0.5 dpa</b> , at 300K, <b>no pre-annealing</b> , exposed to D atoms at 450K
2. A0781A	<b>0.5 dpa</b> , at 300K, annealed at <b>600K</b> for 1h, exposed to D atoms at 450K
3. A0782A	<b>0.5 dpa</b> , at 300K, annealed at <b>800K</b> for 1h, exposed to D atoms at 450K
4. A0783A	<b>0.5 dpa</b> , at 300K, annealed at <b>1000K</b> for 1h, exposed to D atoms at 450K
5. A0785A	<b>0.5 dpa</b> , at 300K, annealed at <b>1130K</b> , exposed to D atoms at 450K

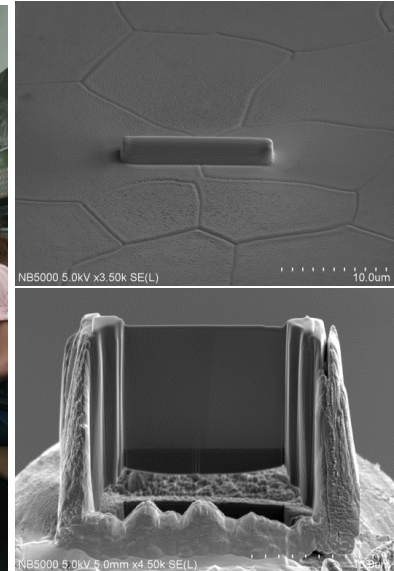
# TEM on self-damaged W. Defect annealing.



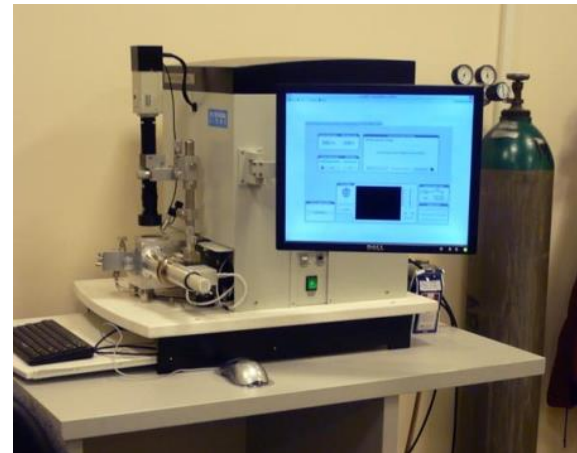
0. Self-ion damaged W plate from IPP  
W<sup>6+</sup> ions, 3 MV



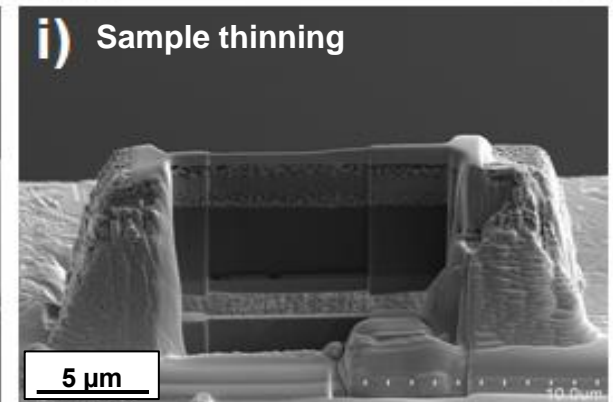
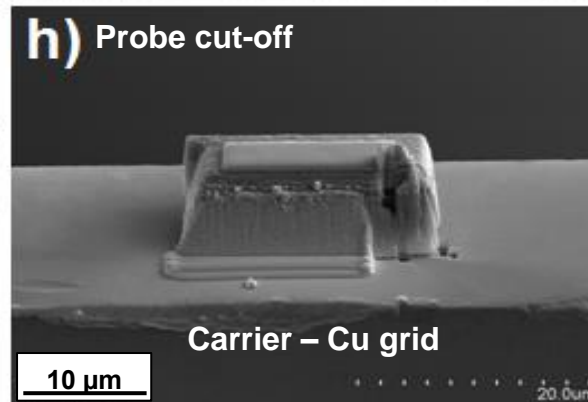
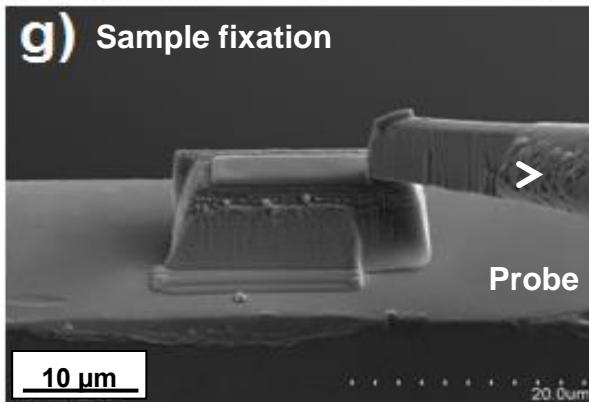
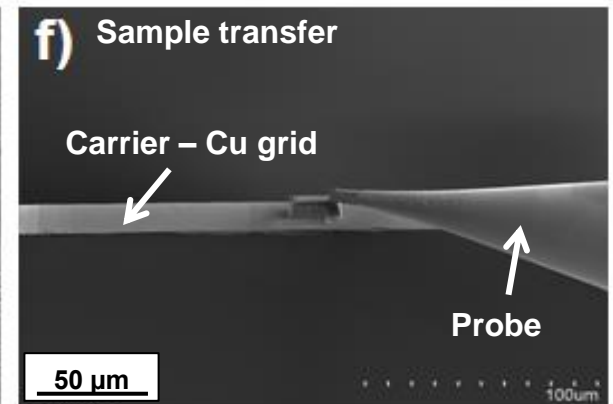
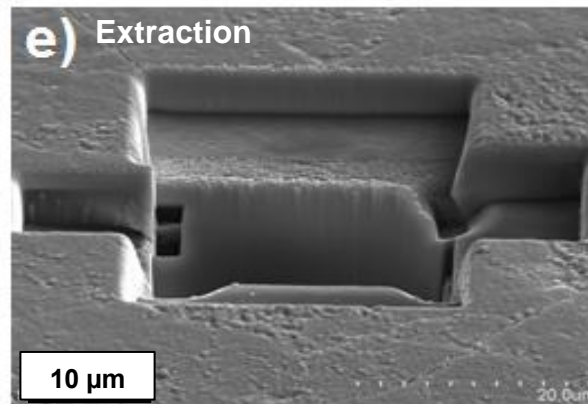
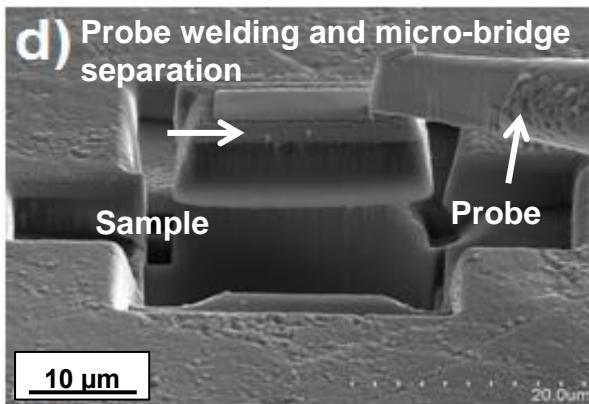
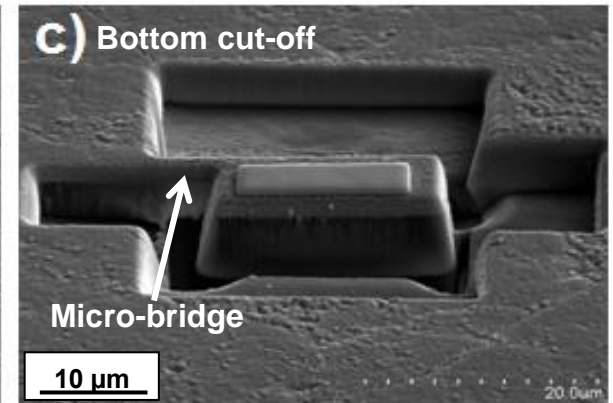
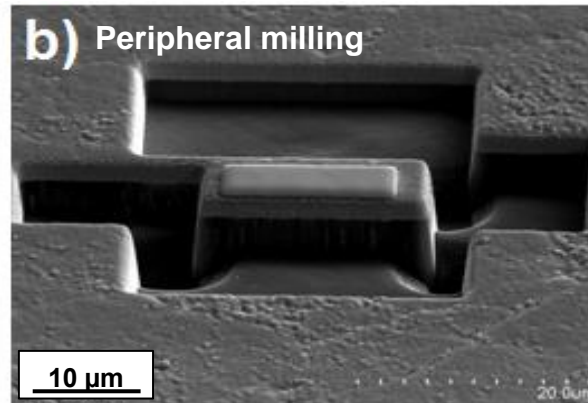
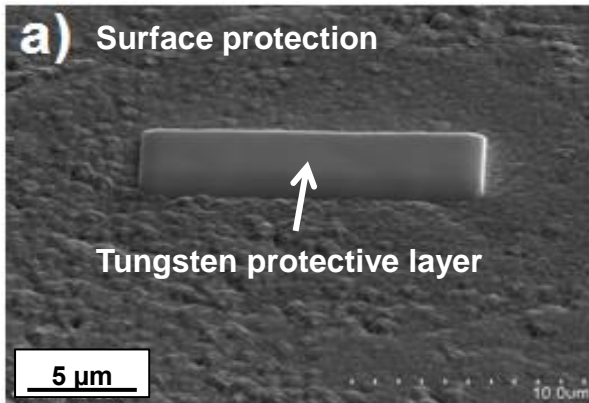
1. FIB milling – thickness 200-250 nm  
Ga ions, 40 kV, HITACHI NB5000



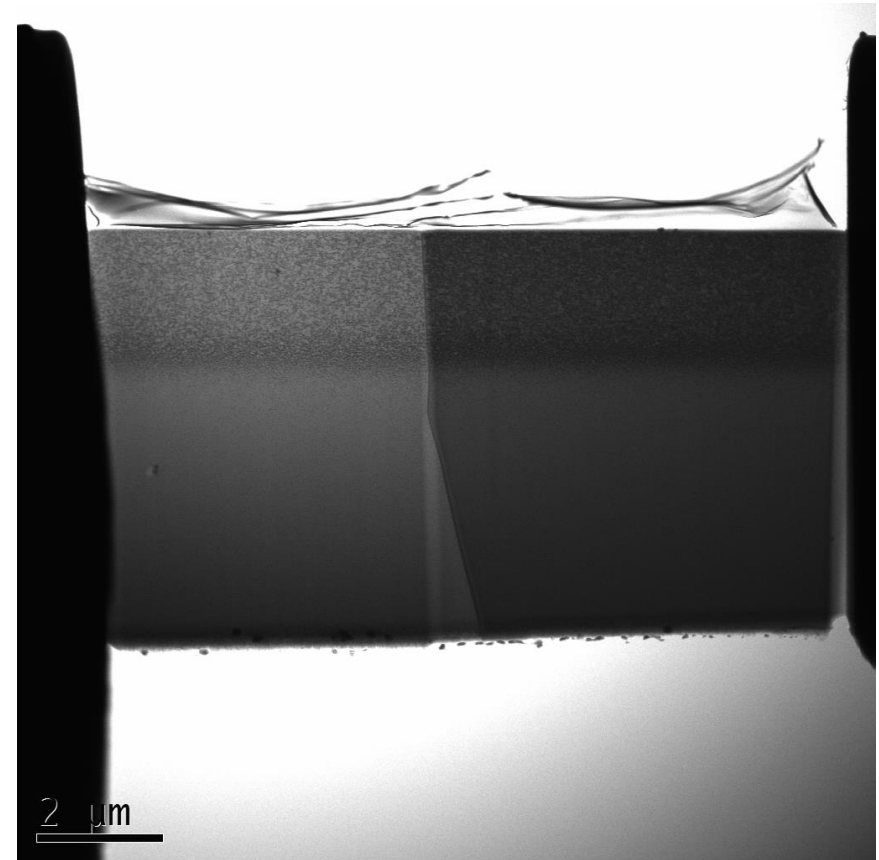
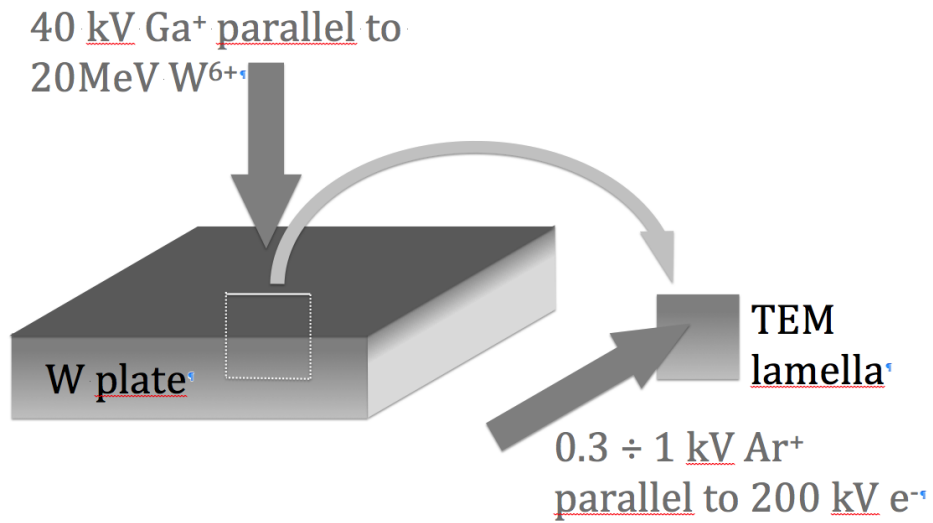
2. Thinning (gentle milling) –  
Ar ions, 1kV to 500 V



# TEM on self-damaged W. Defect annealing.

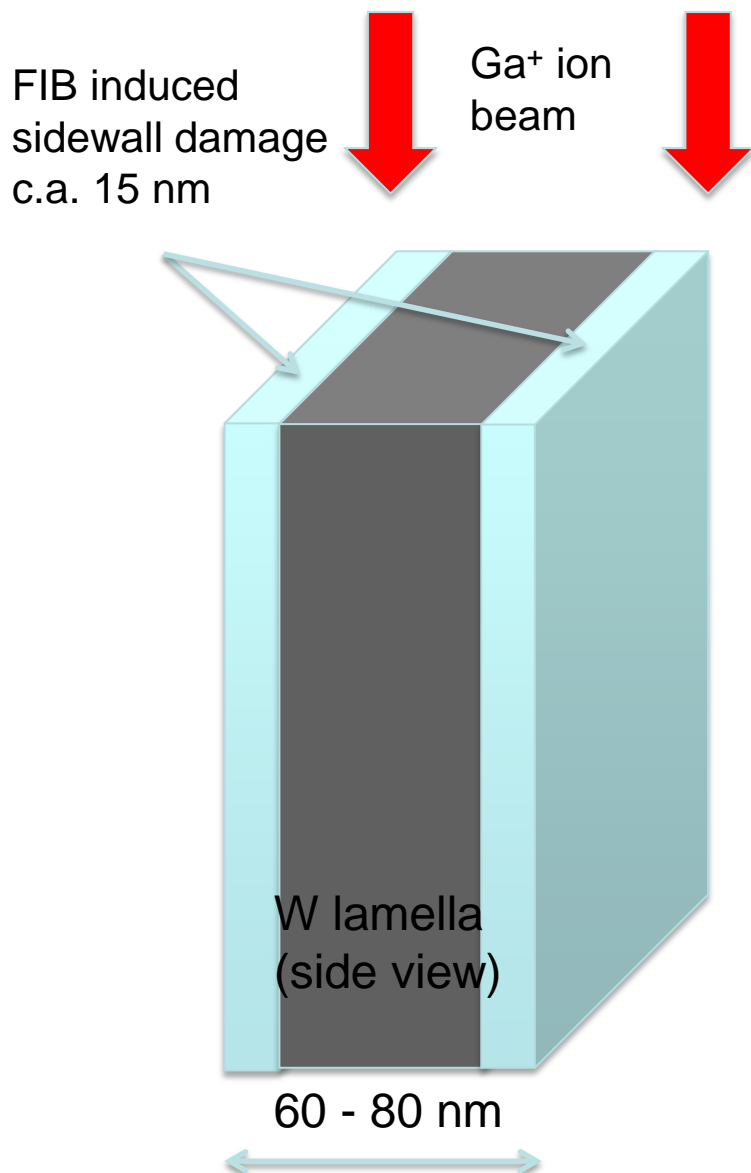


# TEM on self-damaged W. Defect annealing.



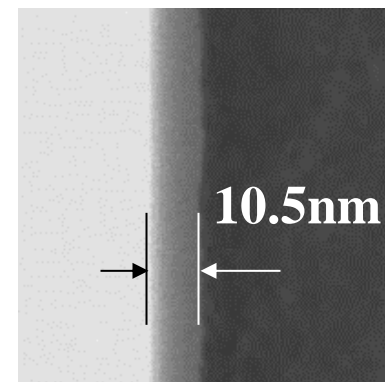
W lamella

# TEM on self-damaged W. Defect annealing.

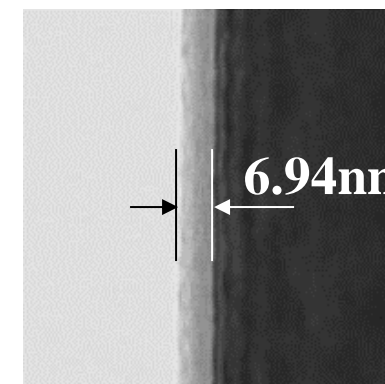


Damage layer thickness as a function of final polishing kV.

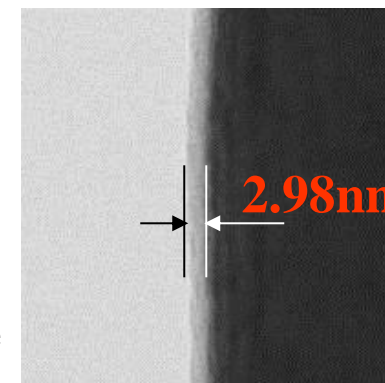
10kV



5kV



2kV



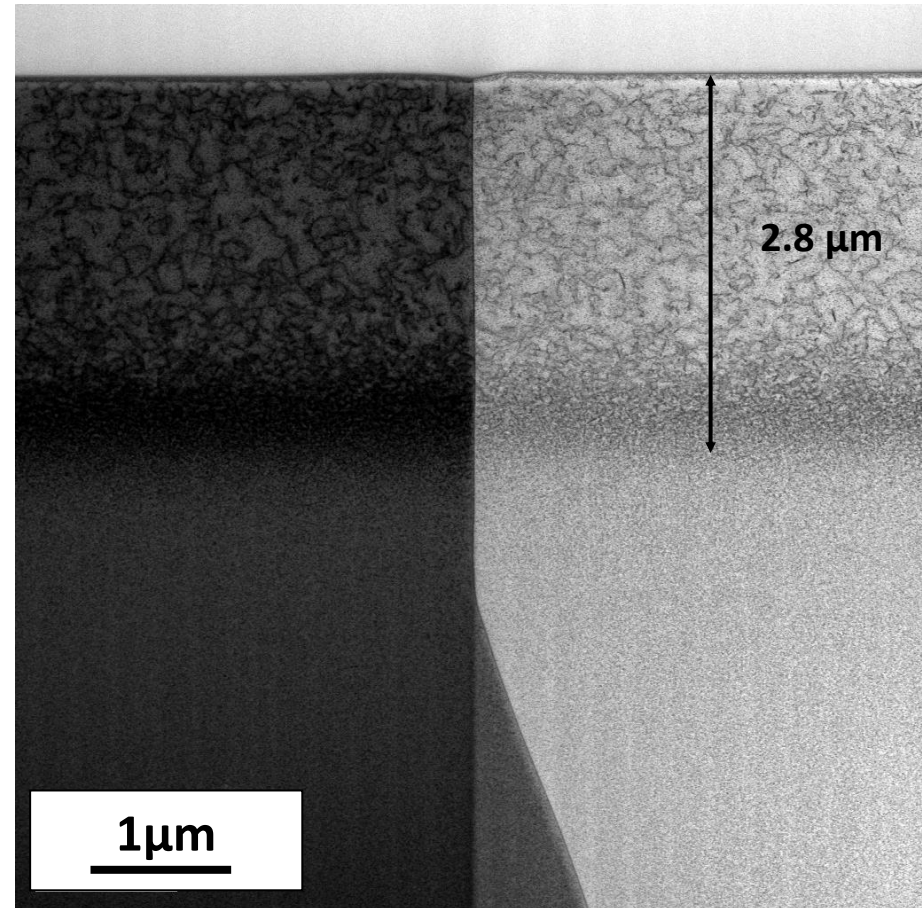
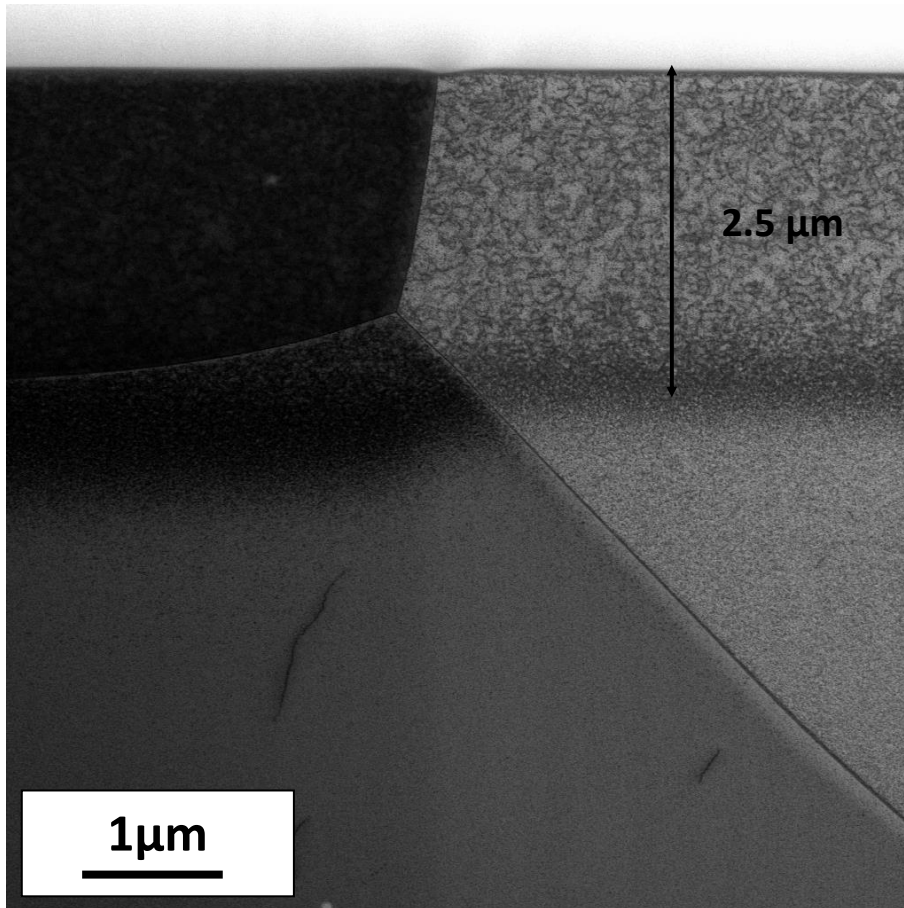
HITACHI Hi-Technologies  
Specimen: Si single crystal  
Remarks: 300kV TEM image

# TEM on self-damaged W. Defect annealing.



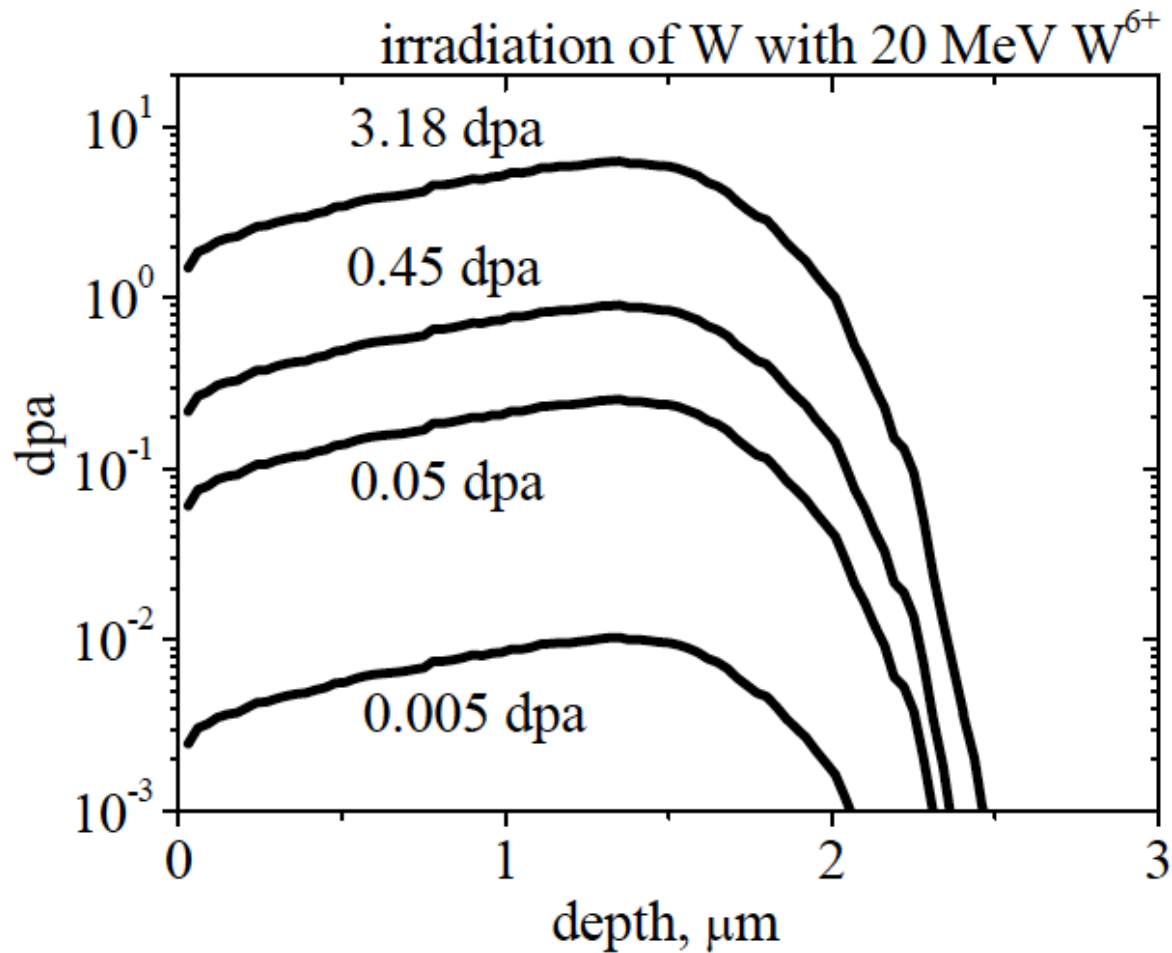
$3.7 \cdot 10^{18} \text{ W/m}^2$  (1.17 dpa)

$1 \cdot 10^{19} \text{ W/m}^2$  (3.18 dpa)



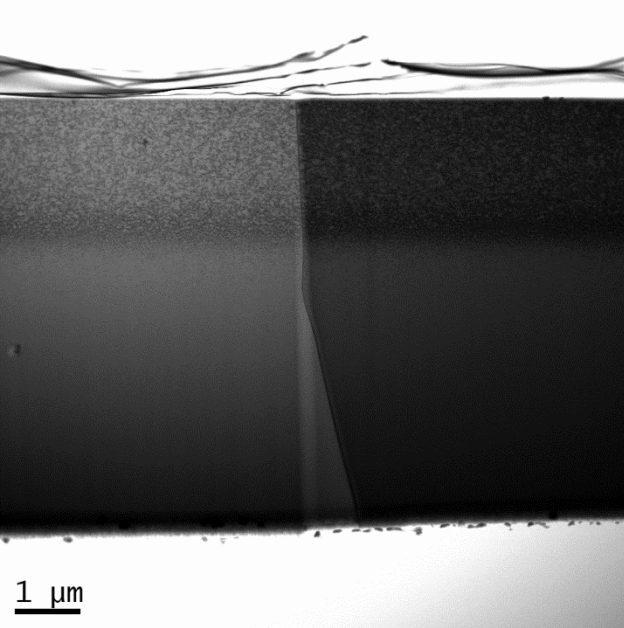


# TEM on self-damaged W. Defect annealing.

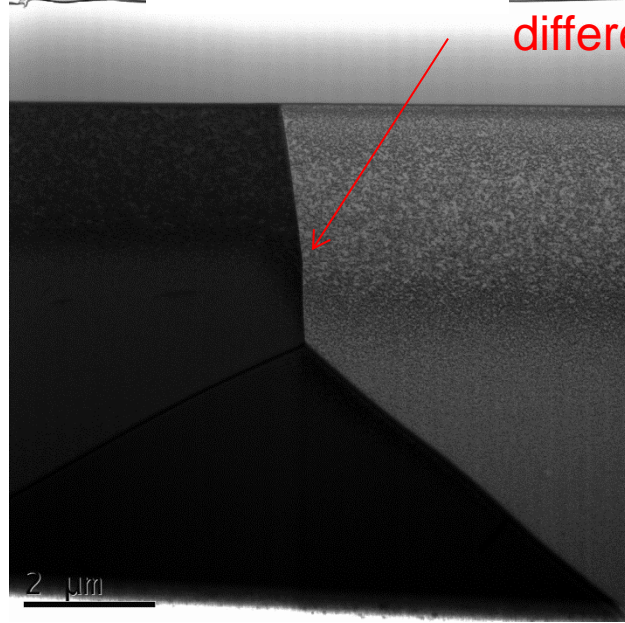


O.V. Ogorodnikova et. al., 2013, IPP

**A0 780A**  
**No annealing**

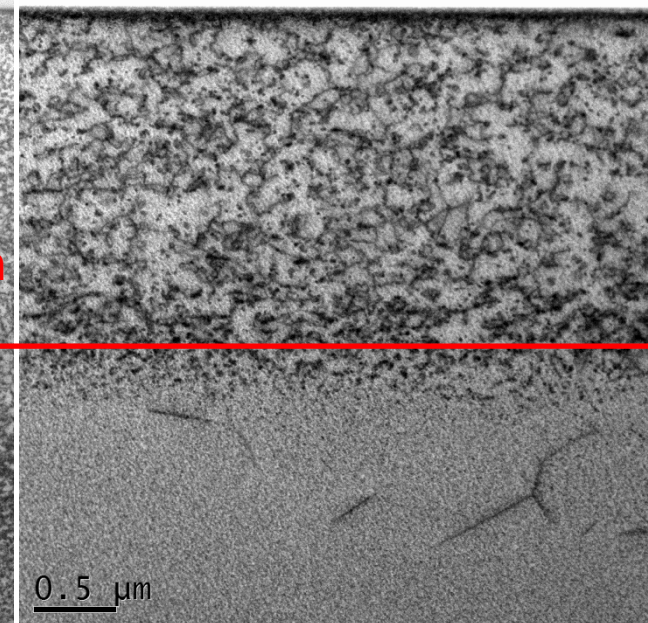
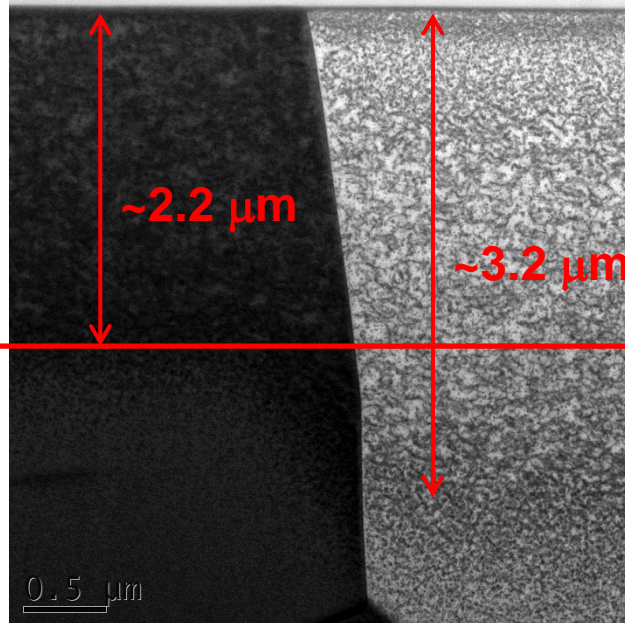
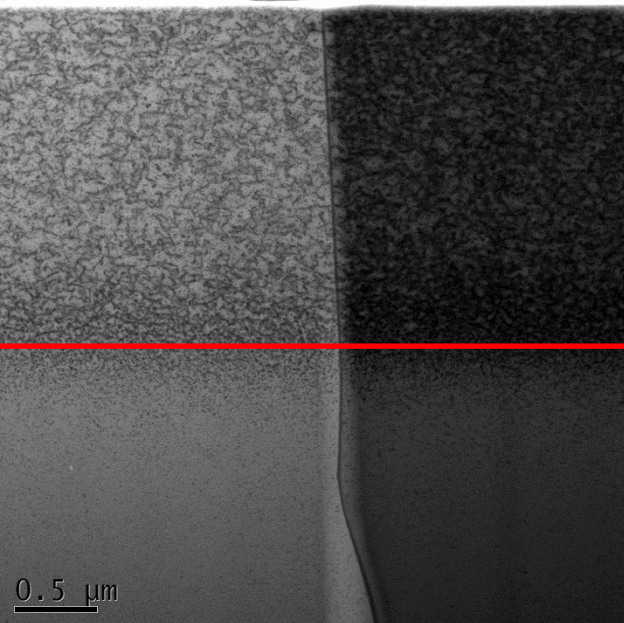
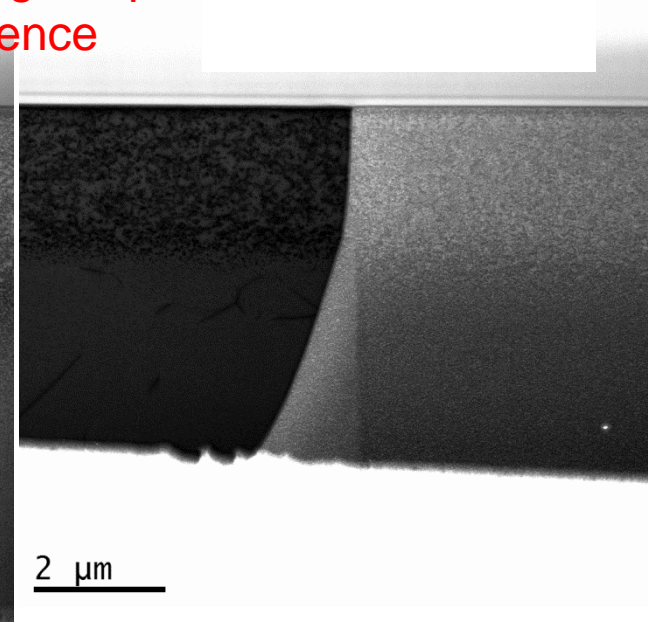


**A0 782A**  
**800 K**

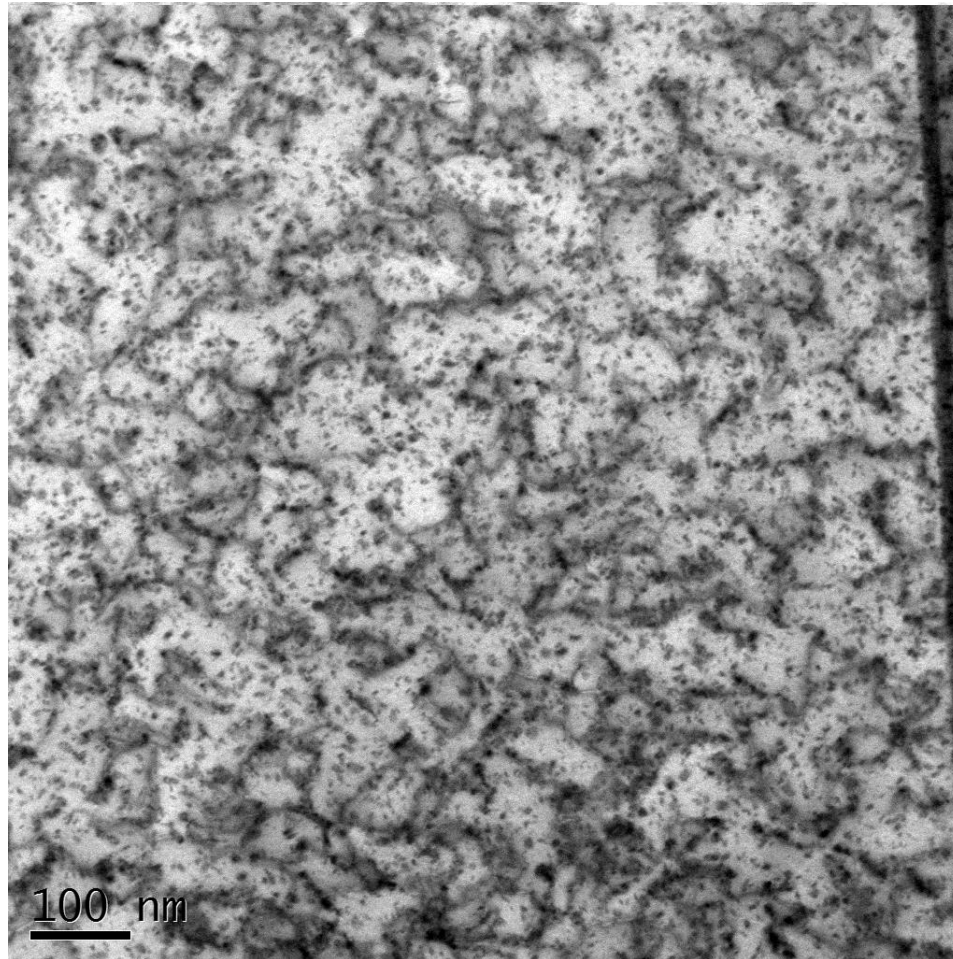


**Implantation  
damage depth  
difference**

**A0 785A**  
**1130 K**

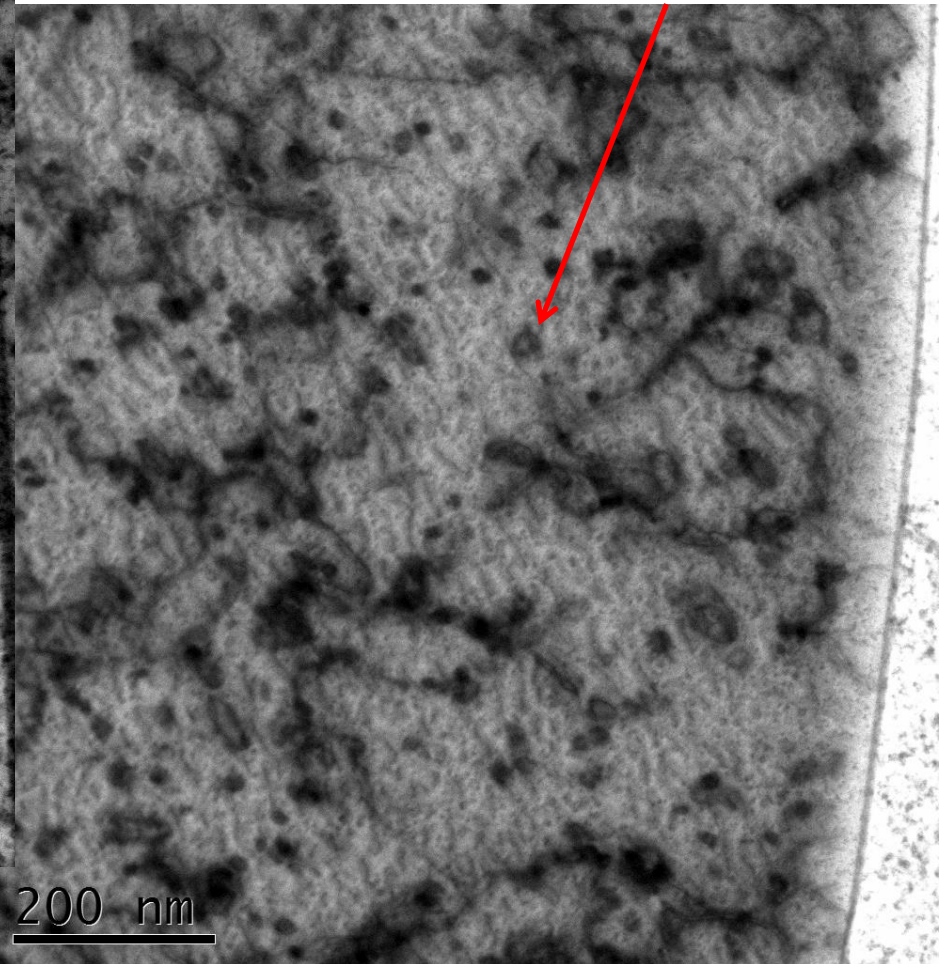


**A0 780A**  
no annealing



**A0 785A**  
annealed  
at 1130K

Larger dislocation  
loops + lower  
defect density



No annealing

600K

800K

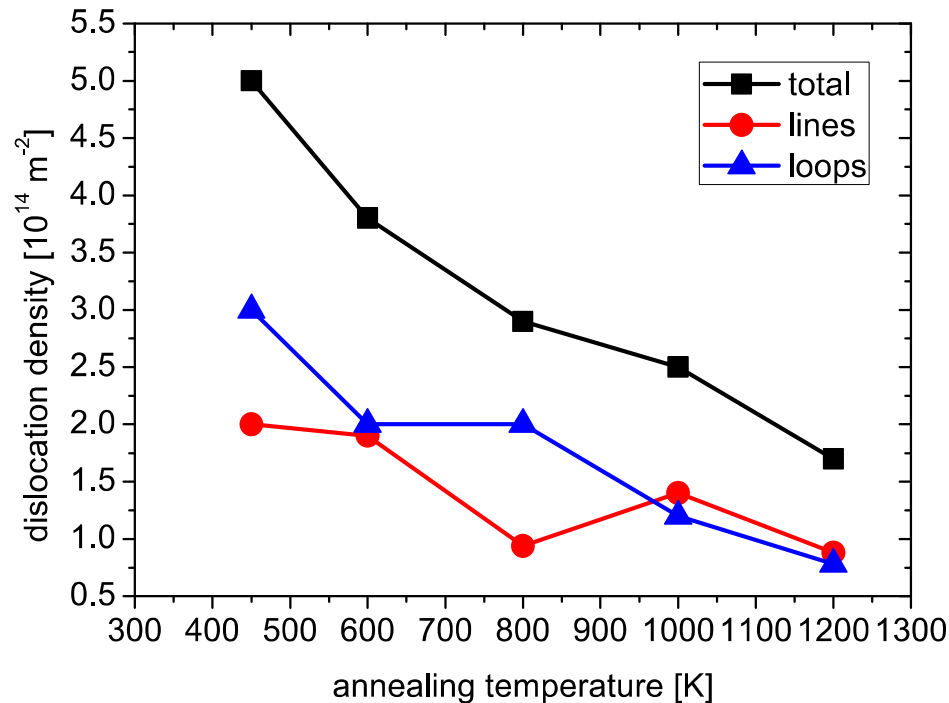
1000K

1130K

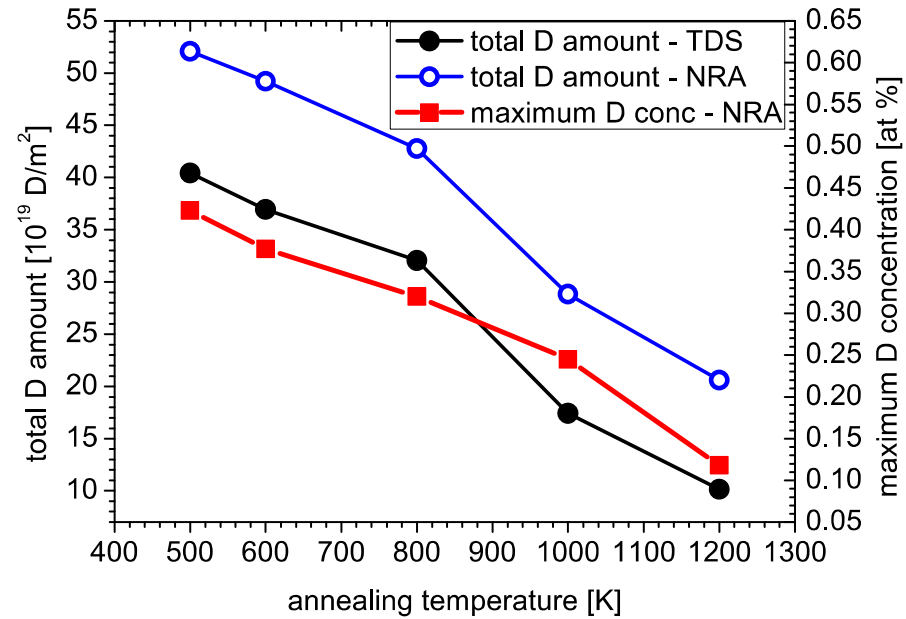
50 nm



## Dislocation density



## D concentration

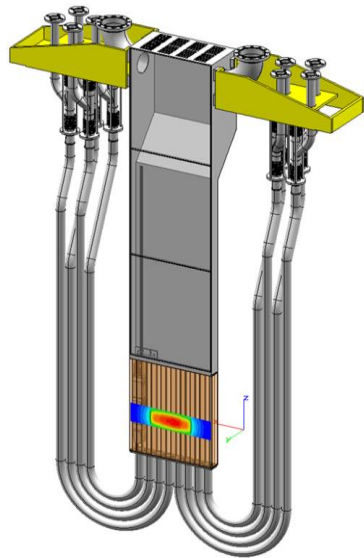


Data from JSI: A. Založnik, S. Markelj

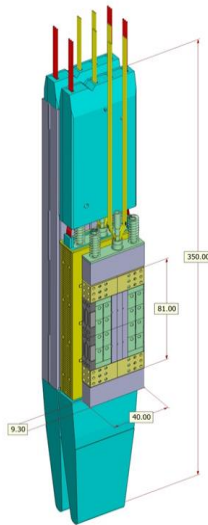
“Dislocation density drops by **66 %** for the highest annealing temperature compared to the unannealed sample. This is in good agreement with the total D concentration results obtained by NRA and TDS, where also **60 %** decrease was observed.”

## Part II – Miniaturized sample testing

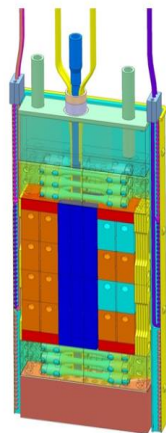
Why we need small samples in IFMIF / DONES?



HFTM Assembly



Packet of 3 Rigs



Cut-open capsule  
with specimens

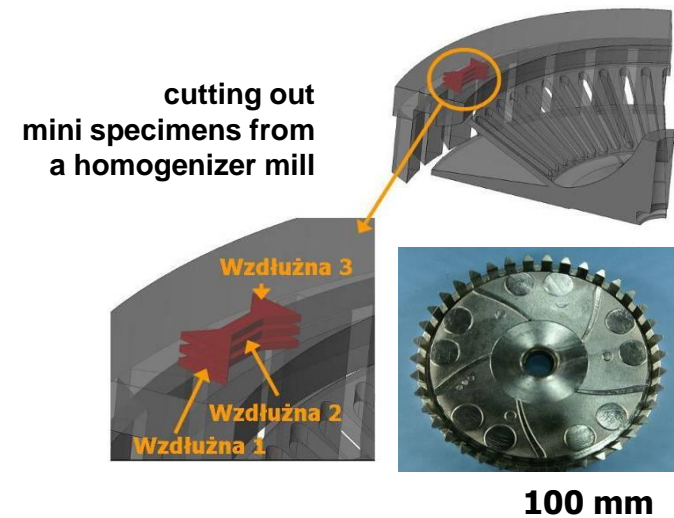
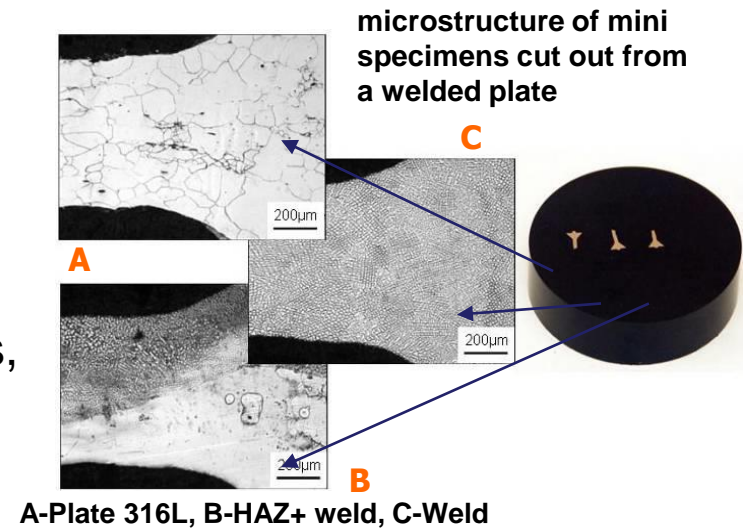
- Limited space for specimens in the irradiation capsule / limited HF volume
- For reliable engineering data for DEMO design many samples needed.
- Handling of active samples is “easier” when they are small

Source: <http://www.ifmif.org>

Is IFMIF / DONES the only reason to develop miniaturized sample testing methods?

## Motivation to use miniaturized samples

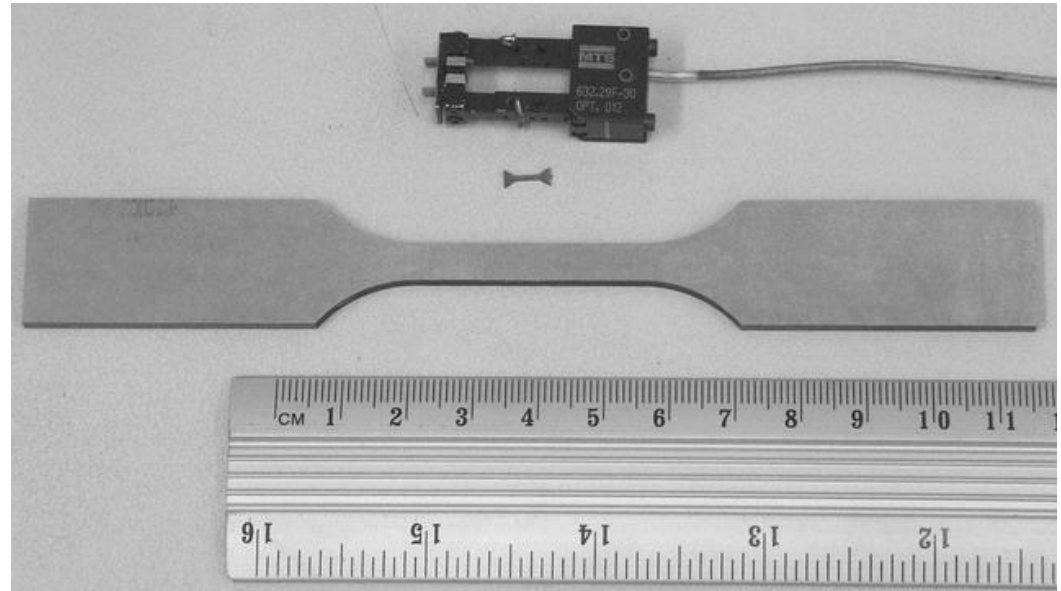
- Material / technology related: nanomaterials, weld heat affected zones, layers and coatings, gradient materials
- Design related: small cross section, complex shape (e.g. gear parts)
- Cost related: low invasiveness of the inspection vs. repair costs





## Challenges

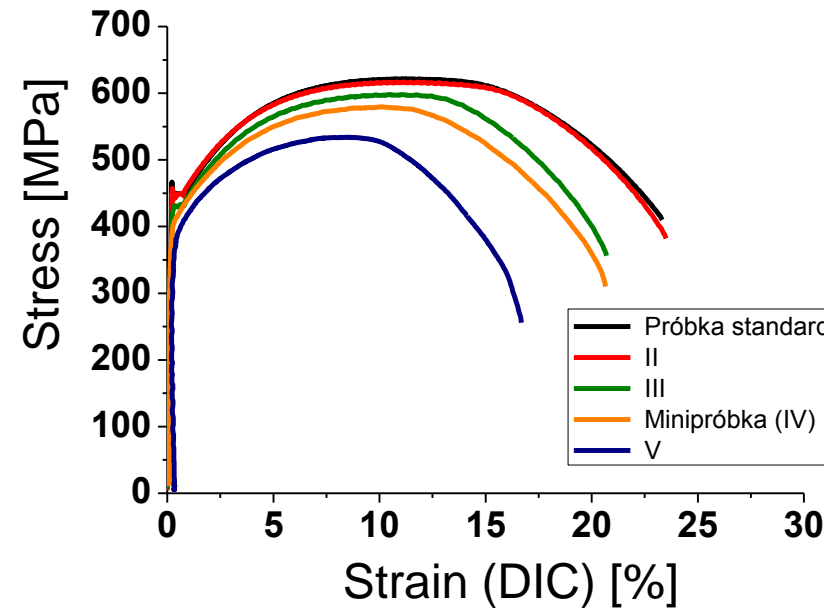
- Technical issues
  - Samples preparation
  - Gripping
  - Strain measurement
  - Alignment
  - Loading stability
  - .....
- Size effect issues
  - Relative volume of “surface layer”
  - Microstructure elements / sample size relation
  - Sample geometry
  - .....



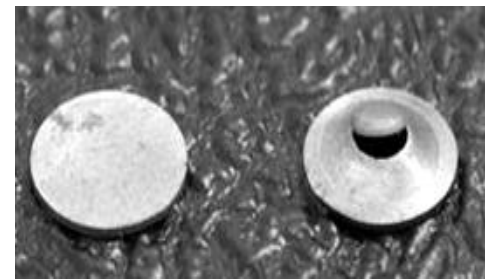
Standard and mini specimen for tensile test

## Types of tests carried out at small samples at WUT

- Static Tensile Test
- Mini Disc Bend Test (MDBT)
- Fatigue Crack Growth (FCG)

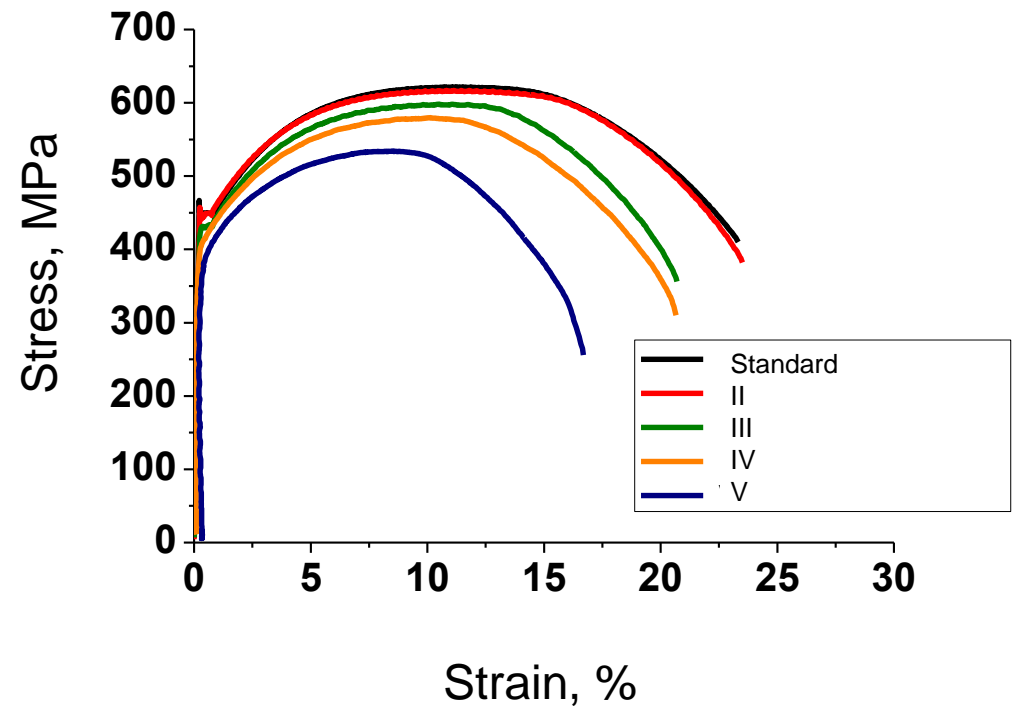
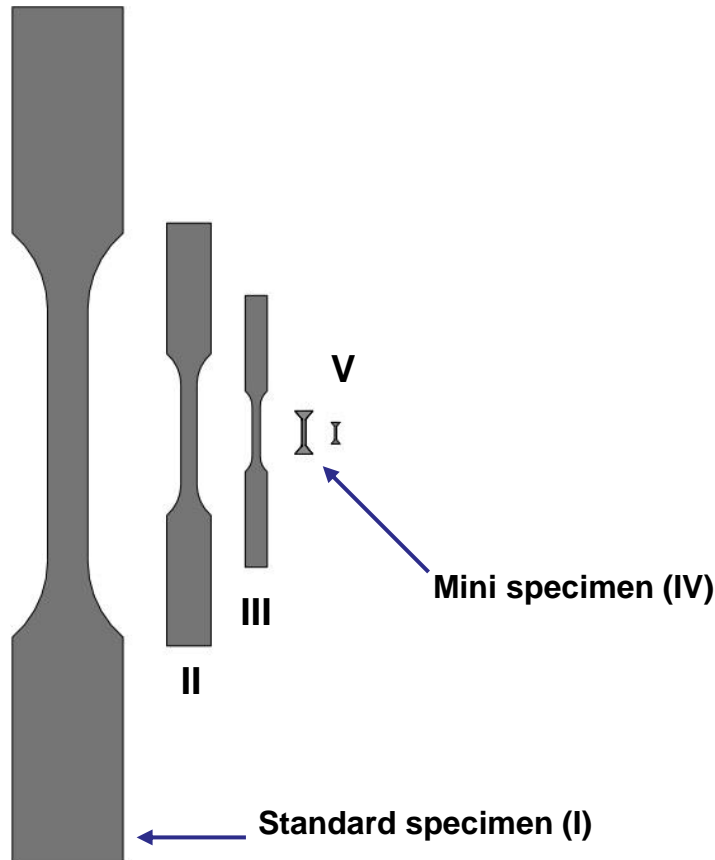


FCG test sample gripping system

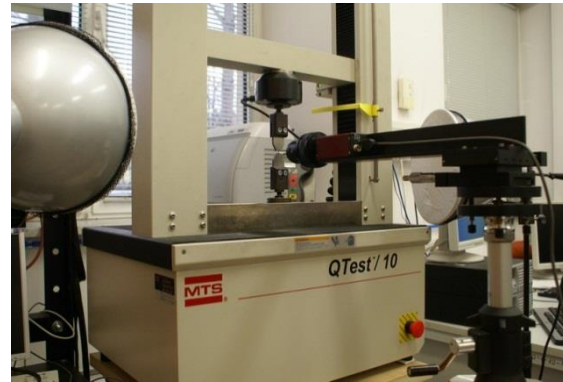
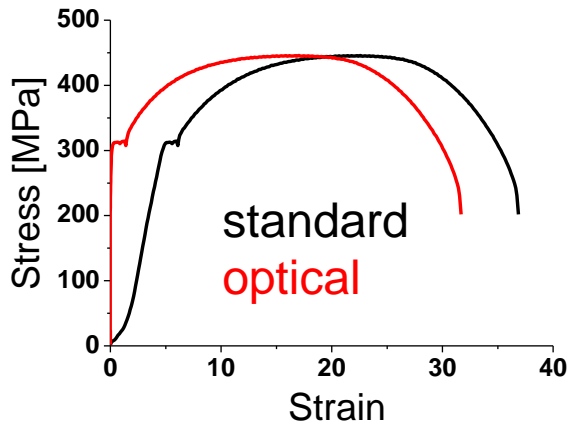


Samples before and after the MDBT

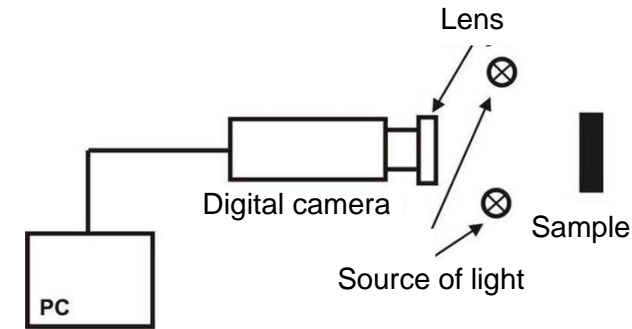
## Size of specimens for static tensile tests



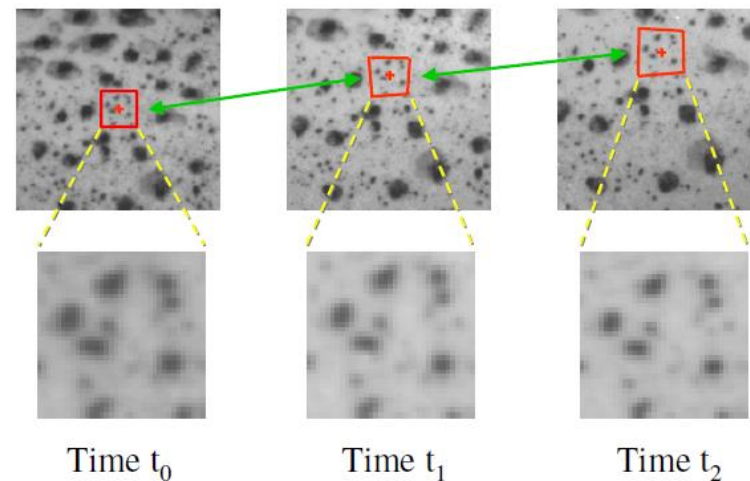
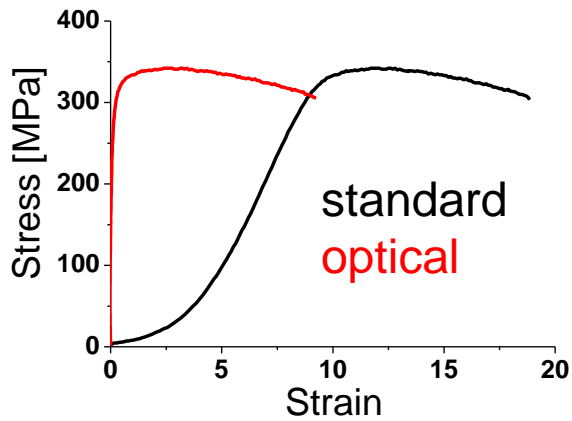
## Reliable strain measurements – optical method



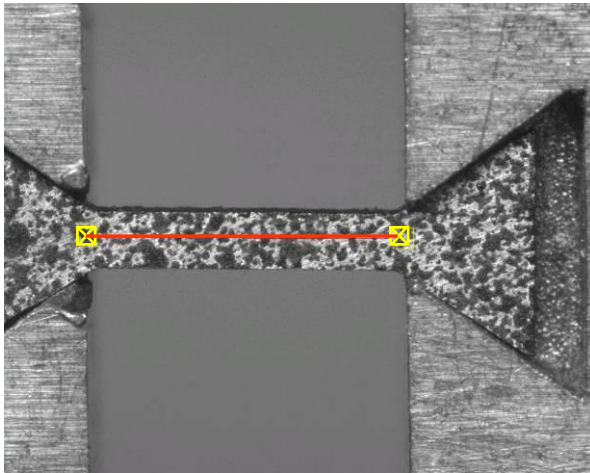
Stand for tensile tests



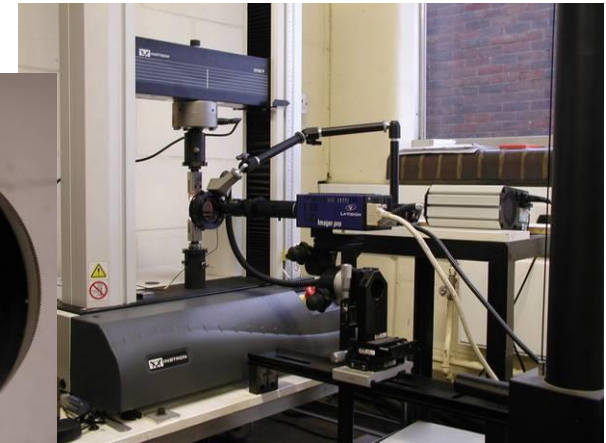
Scheme of DIC stand



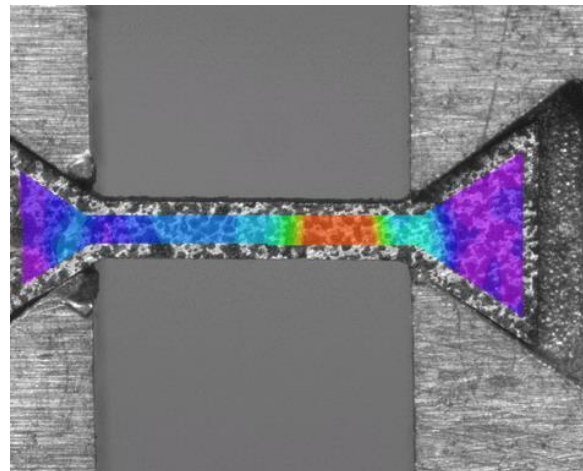
## Optical method – Digital Image Correlation (DIC)



**Optical extensometer**



**Testing stand setup**

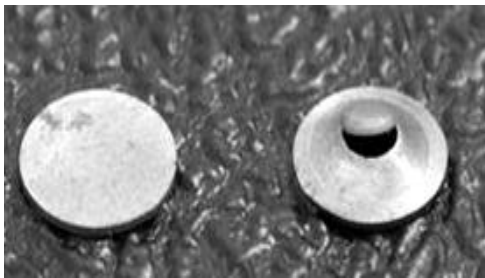


**Strain field on the mini specimen surface**

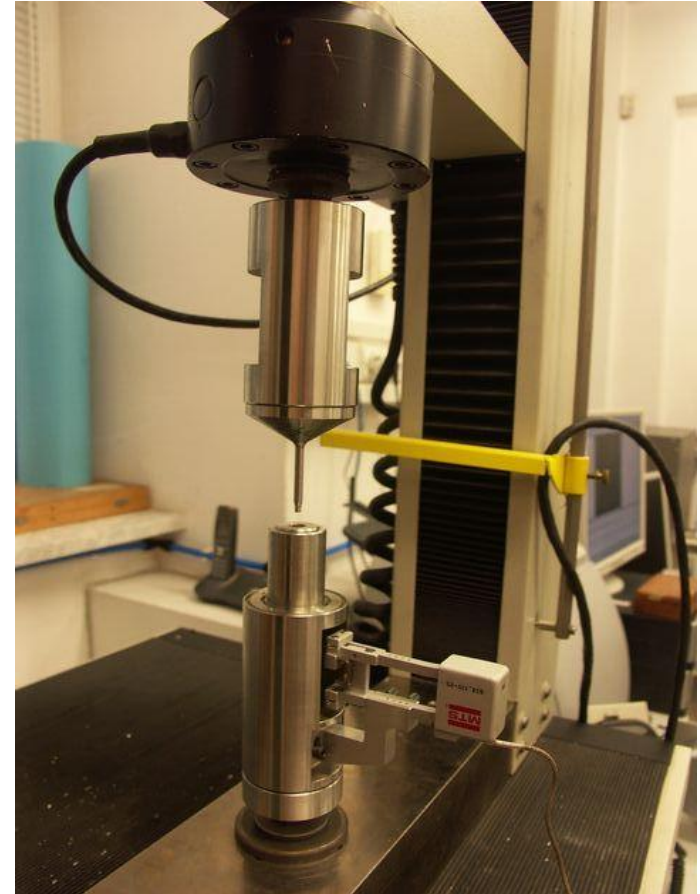
## Miniaturized disc bend test



The LN container

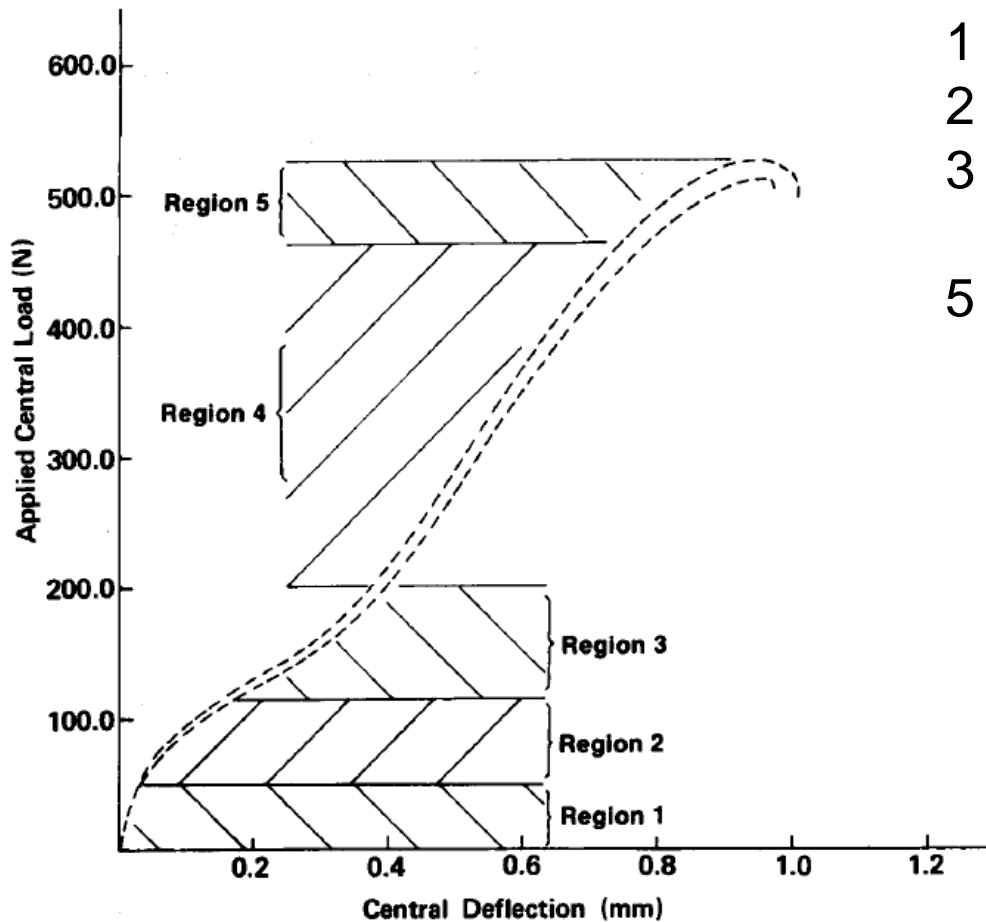


Samples before and after  
the MDBT



MDBT stand at WUT

## The deformation stages during MDBT



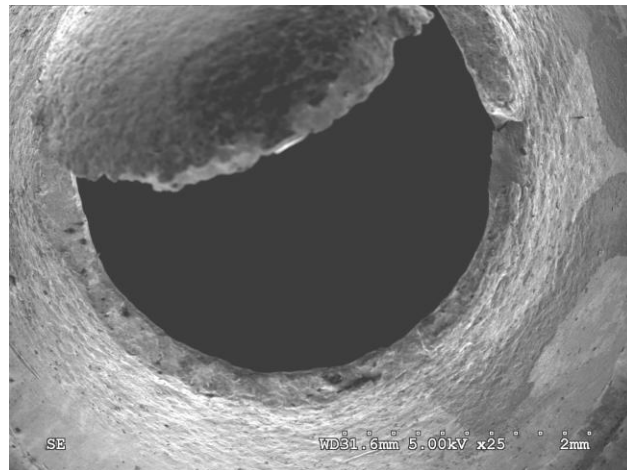
- 1 - elastic regime,
- 2 - elastoplastic regime,
- 3 - 4 – plastic deformation and strengthening
- 5 – crack initiation and propagation



M.P. Manahan „A new postirradiation mechanical behavior test - the Miniaturized Disk Bend Test”, Nuclear Technology, Vol . 63, nov 1983

## MDBT “applications”

- Strength of the material – correlation with YS and UTS
- Ductile to brittle transition temperature – correlation with Charpy Impact Test
- Crack resistance – correlation with  $K_{IC}$  i  $J_{IC}$  obtained in CT test



← cylinder  
puncher  
shape  
sphere →





## Fatigue Crack Growth testing

### Set-up for FCG rate ( $dA / dN$ ) testing

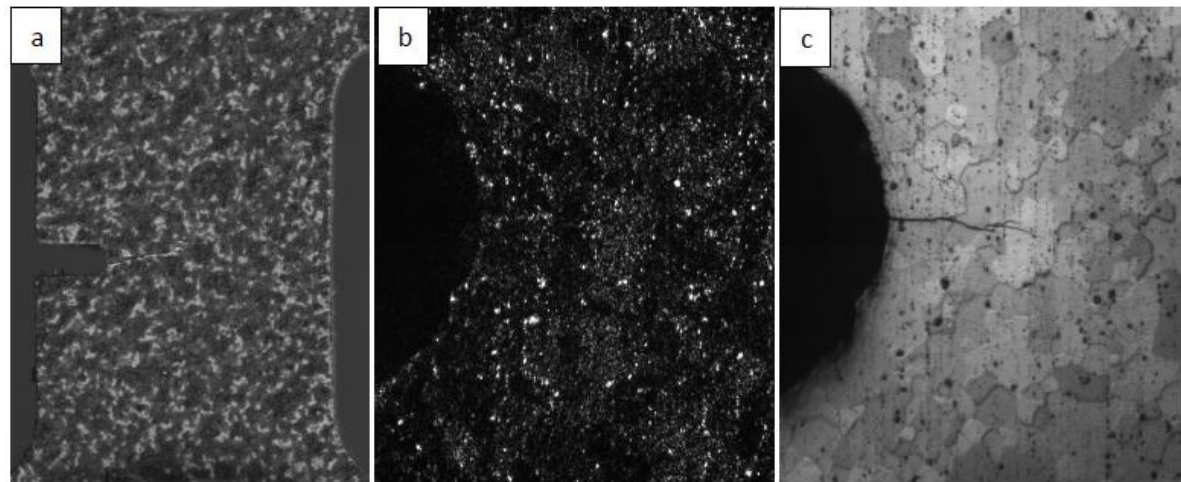
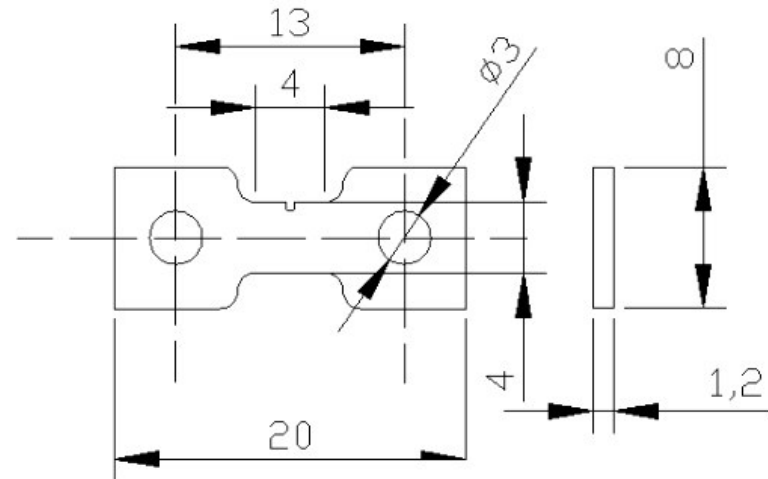
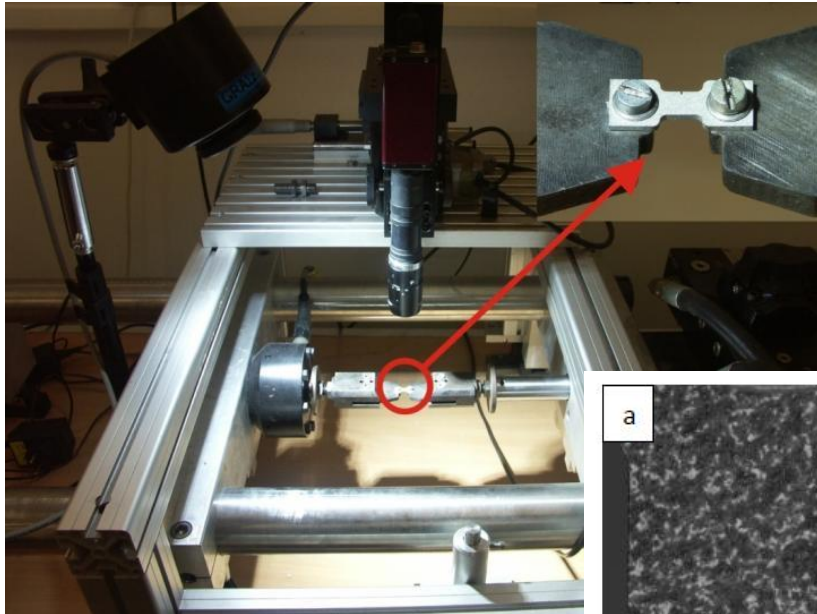


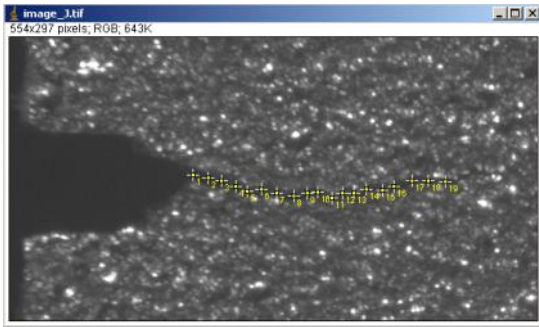
Figure 1: Sample surface pattern: a-small magnification set-up, b-large magnification set-up with laser light, c-large magnification setup with white light and polarizing filters

T. Brynk et al., 2010

## Fatigue Crack Growth testing

### Mini-samples testing with optical crack length measurements

#### Manual crack tip tracking

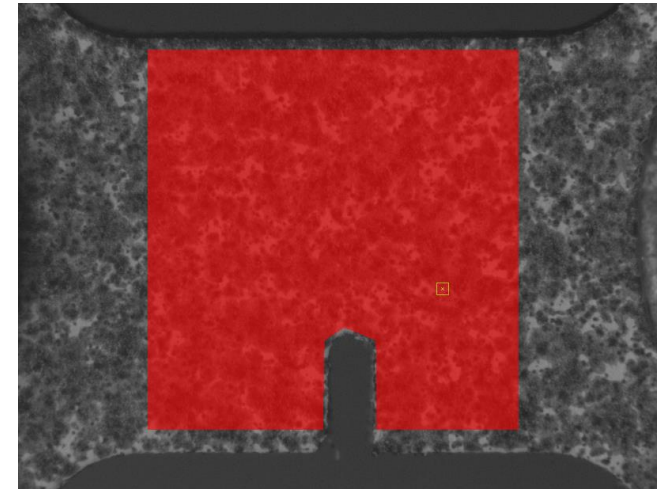


$$K_{\max} = \left( \frac{P}{Wt} \right) (\pi a)^{1/2} \cdot M_f$$

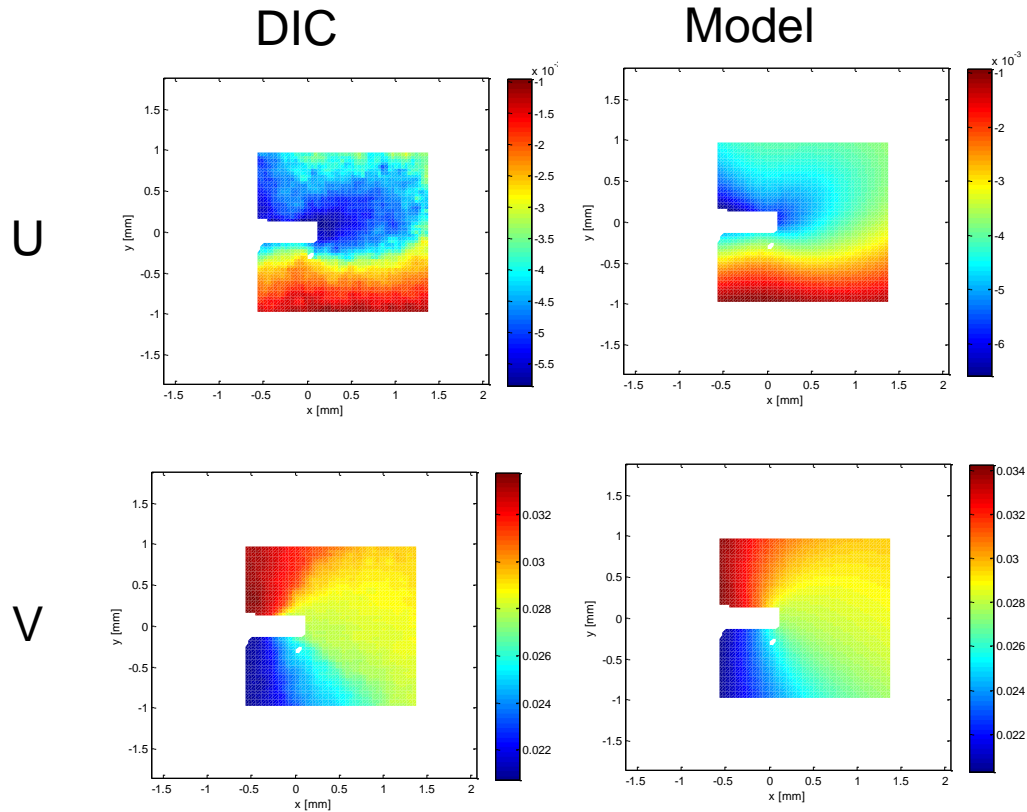
$$M_f = \left\{ 1,12 - 0,231 \left( \frac{a}{W} \right) + 10,55 \left( \frac{a}{W} \right)^2 - 21,72 \left( \frac{a}{W} \right)^3 + 30,39 \left( \frac{a}{W} \right)^4 \right\}$$

$a$  – crack length,  $W$  - sample width,  $t$  - sample thickness,  $P$  – maximal force

#### DIC and inverse method



## da/dN tests of ECAPed Al 5483



$$K_I = 14.9 \text{ MPa}\cdot\text{m}^{0.5}; K_{II} = 1.6 \text{ MPa}\cdot\text{m}^{0.5};$$

$$x_0 = 0,74 \text{ mm}; y_0 = 0,21 \text{ mm}$$

## Summary

- ❖ Investigations of radiation damage in tungsten have been successfully carried out at WUT since 2011 in cooperation with foreign fusion laboratories.
- ❖ The estimated dislocations densities correlate with the amount of deuterium trapped in the material.
- ❖ Miniaturized samples testing is developed at WUT for more than 10 years.
- ❖ Considerable experience and knowledge have been gathered for different type of mechanical tests.
- ❖ The tests are used in practice to evaluate degradation of properties of components being in service at industry.